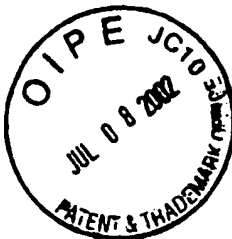


I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS
BEING DEPOSITED WITH THE UNITED STATES POSTAL
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of :

July 1, 2002

BASANTH JAGANNATHAN, ET AL. :

Group Art No.: 2823

Serial No. 09/843,783 :

Examiner: William D. Coleman

Filed: April 30, 2001 :

IBM Corporation
Bldg. 300, Zip 482
2070 Route 52
Hopewell Junction, New York 12533

Title: METHOD TO INCREASE
CARBON AND BORON DOPING
CONCENTRATIONS IN SI AND SIGE
FILMS :

LETTER TO OFFICIAL DRAFTSMAN

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Kindly amend Fig. 1 as shown in RED on the attached, per the Examiner's objection
#2 of the Office Action dated 05/06/2002.

Respectfully submitted,
BASANTH JAGANNATHAN, ET AL.

By:

Joseph P. Abate 7-1-02
Joseph P. Abate, Attorney
Registration No. 30,238
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JPA/lbg